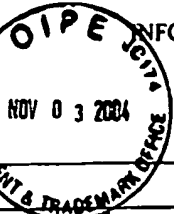


FORM PTO-1449

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Patent and Trademark OfficeAtty. Docket No.  
P24284Application No.  
10/665,011

INFORMATION DISCLOSURE STATEMENT  
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Applicant  
Akira GYOUTOKU et al.Filing Date  
September 22, 2003Group  
2879 2851

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>HEL</i>		6 1 0 7 7 3 4	08/22/00	TANAKA et al.	-	-	
		6 3 3 7 4 9 2	01/08/02	JONES et al.	-	-	
		6 4 2 0 0 3 1	07/16/02	PARTHASARATHY et al.	-	-	
		6 2 7 4 9 8 0	08/14/01	BURROWS et al.	-	-	
		6 4 7 2 8 1 7	10/29/02	KAWASE	-	-	
		6 4 6 9 4 3 7	10/22/02	PARTHASARATHY et al.	-	-	
		6 5 6 6 8 0 6	05/20/03	KAWAI	-	-	
	2002	/ 1 7 6 9 9 2	11/28/02	PARTHASARATHY et al.	-	-	
<i>HEL</i>	2004	/ 0 1 6 1 1 9	08/19/04	HAMANO et al.	-	-	

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES	TRANSLATION NO
<i>HEL</i>		1 0 9 8 3 7 6	05/09/01	E.P.O	-	-		
	0	0 / 7 0 6 9 0	11/23/00	W.I.P.O	-	-		
	1	0 0 2 6 2 3 6	03/01/01	GERMANY	-	-		
	2003	- 4 5 6 7 6	02/14/03	JAPAN	-	-		
	11	- 3 2 9 7 4 9	11/30/99	JAPAN	-	-		
<i>HEL</i>	2004	/ 0 5 5 8 9 7	07/01/04	W.I.P.O	-	-		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>HEL</i>	1	J. KIDO et al., "High Quantum Efficiency Organic EL Devices Having Charge Generation Layer". 49 <sup>th</sup> Japan Society of Applied Physics and Related Societies, March 2003, page 1308, XP008035187.
<i>HEL</i>	2	Patent Abstracts of Japan, Vol. 2003, No. 06, June 3, 2003 (See JP 2003-045676 above)
<i>HEL</i>	3	Patent Abstracts of Japan, Vol. 2000, No. 02, February 29, 2000 (See JP 11-329749 above)

EXAMINER *Haichuan*

DATE CONSIDERED 4/21/06

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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